

S/N: 10/ 768,612

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Docket: CS03-048

Reply to the Office action dated March 22, 2005

To: Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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5 From: William J. Stoffel 1735 Market St - Ste A  
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Subject:

S/N: 10/ 768,612  
Docket: CS03-048  
Reply to the Office action dated March 22, 2005  
File date: 1/30/04  
Inventor: Yisuo Li  
Title: **A SEMICONDUCTOR DEVICE LAYOUT AND  
CHANNELING IMPLANT PROCESS**  
  
Group Art Unit: 2812  
Examiner: Lindsay Jr., Walter Lee

**RESPONSE TO PATENT OFFICE ACTION**

15 Dear Sir:

In response to the office action dated March 22, 2005, please consider the following remarks:

**CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being:

20 ☒ FAXED to the central facsimile number of patent and trademark office at the following number (703) 872-9306 or  
☐ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 28, 2005.

25

Signature/Date William J. Stoffel 3/28/05  
William J. Stoffel Reg. No. 39,390 Customer number 30402

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**This response to Office Action has the following sections:**

- **Amendments to the claims** begin the next page of this paper
- **Remarks/Arguments** begin on the page following the amendments to the claims.